



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Tadahiro OHMI et al.

Serial No.: 09/864,376

Filing Date: May 25, 2001

For: PLASMA PROCESSING  
APPARATUS AND PLASMA  
PROCESSING METHOD

Customer No. 004372

Confirmation No.: 1605

Art Unit: 1763

Examiner: Rudy ZERVIGON

Docket No.: 107176-00007

**AMENDMENT UNDER 37 C.F.R. § 1.111**

**Introductory Comments**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

July 11, 2005

Sir:

In response to the Office Action dated March 11, 2005, the period for response being extended from June 11, 2005 until July 11, 2005, by the attached Petition for Extension of Time, please consider the following remarks beginning on page 2.